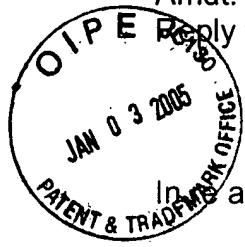


Appl. No. 10/677,929
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Attorney Docket No.: N1085-00154
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In the application of: **Cheng I. Sun**

Examiner: Alexander J.
Kosowski

Serial No.: 10/677,929

Group Art Unit: 2125

Filed: 10/02/2003

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For: **METHOD AND SYSTEM FOR ANALYZING SEMICONDUCTOR FABRICATION**

I hereby certify that this correspondence is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Examiner Alexander J. Kosowski
Mail Stop Non-Fee Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Date: December 29, 2004

W. H. C. House.

Maria E. Provencio

Examiner Alexander J. Kosowski
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION DATED SEPTEMBER 29, 2004

Sir:

Responsive to the Office Action dated September 29, 2004, please re-examine and reconsider the above-identified patent application according to the amendments and remarks provided.

Amendments to the Specification are shown on page 2 of this paper.

Amendments to the Claims are reflected in the Listing of Claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 9 of this paper.

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